

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****Applicant :** MORITA, Yoshitsugu et al.**Int. App. Serial No.:** PCT/JP2004/004228**Group Art Unit:** Unknown**Atty. No. :** 71,051-020**Examiner:** Unknown**Filed :** Herewith**Title :** SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THEREOF

---

**PRELIMINARY AMENDMENT****MAIL STOP PCT****Commissioner for Patents**

P.O. Box 1450

Alexandria, Virginia 22313-1450

Dear Sir:

In reference to the above-referenced patent application, please enter the following Preliminary Amendment and consider the accompanying remarks prior to examination on the merits. A complete listing of all claims pending in the application is included as required under 37 CFR § 1.121.